

<b>Notice of References Cited</b>	Application/Control No. 09/811,879	Applicant(s)/Patent Under Reexamination JAGIELSKI ET AL.	
	Examiner Duy K Le	Art Unit 2685	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,862,458	01-1999	Ishii, Junichi	455/107
	B	US-5,991,643	11-1999	Chao-Cheng, Chen	455/575.7
	C	US-5,491,715	02-1996	Flaxl, Thomas J.	375/344
	D	US-6,018,324	01-2000	Kitchener, Dean	343/795
	E	US-2001/0044283 A1	11-2001	YAJIMA, YUJI	455/107
	F	US-6,625,428	09-2003	Finnell et al.	455/115.1
	G	US-6,005,891	12-1999	Chadwick et al.	375/224
	H	US-5,722,056	02-1998	Horowitz et al.	455/126
	I	US-5,450,088	09-1995	Meier et al.	342/51
	J	US-3,662,294	05-1972	Jacobs et al.	333/33
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.